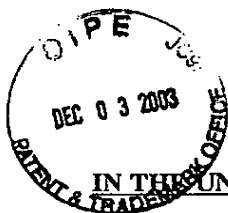


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DEC 05 2003

Express Mail No. ER074143284US
Attorney Docket No.: AM-2602.C1

AF/1700

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

IN RE APPLICATION OF: Jeng H. Hwang et al.

SERIAL NO.: 10/057,674

FILED: January 24, 2002

FOR: MASKING METHODS AND ETCHING
SEQUENCES FOR PATTERNING ELECTRODES
OF HIGH DENSITY RAM CAPACITORS

§ GROUP ART UNIT: 1756
§
§ EXAMINER: N. Barreca
§
§
§
§ Attorney Docket No.:
§ AM-2602.C1
§

Date: December 3, 2003

**AMENDMENT "C" UNDER 37 CFR § 1.116
TRANSMITTAL LETTER**

Hon. Commissioner for Patents
P.O. Box 1450
Alexandria, Virginia 22313-1450

RECEIVED
DEC 09 2003
TC 1700

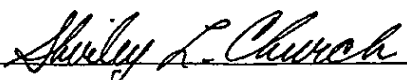
Sir:

Transmitted herewith is applicants' Amendment "C" in response to the final Office Action mailed October 3, 2003, having a shortened statutory period for response of January 3, 2004. This Amendment "C" is being submitted within two (2) months of the mailing date of the Final Rejection, to permit time for an Advisory Action.

CERTIFICATE OF MAILING UNDER 37 CFR § 1.10

I hereby certify that this paper is being deposited with the U.S. Postal Service on the date shown below with sufficient postage as U.S. EXPRESS MAIL NO. ER074143284US in an envelope addressed to: Mail Stop AF, Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450.

Date: December 3, 2003


Shirley L. Church, Reg. No. 31,858